



PATENT
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UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:) Group Art Unit: 1724
V. Sivaramakrishnan et al.)
Serial No: 09/919,633)
Filed: July 31, 2001)
For: **VAPORIZING REACTANT**)
LIQUIDS FOR CHEMICAL VAPOR)
DEPOSITION FILM PROCESSING)

**RESPONSE TO OFFICE ACTION DATED
AUGUST 18, 2003**

CERTIFICATE OF MAILING

I hereby certify that the correspondence enclosed herein is being deposited as first class mail with the United States Postal Service on this date November 20, 2003, in an envelope addressed to: Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450.

By: Saundra D. Hunter
Saundra D. Hunter

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

This paper is being filed in response to an Office Action dated August 18, 2003. Applicants respectfully request a one-month extension of time and submit herewith the requisite fee pursuant to 37 CFR § 1.17(a)(1). Applicants respectfully request reconsideration of the pending claims in view of the arguments presented herein.

R E M A R K S

The August 18th Office Action presented a second restriction requirement, an objection to the drawings, and a nonstatutory double patenting rejection under the judicially created doctrine of obviousness-type double patenting. Claims 10-28 are currently pending in this action. Claim 28 was withdrawn from consideration after applicants elected claims 10-27 in response to a first restriction requirement between claims 10-27 and claim 28.

The Restriction Requirement

The examiner has presented a second restriction requirement to one of the following inventions as required under 35 U.S.C. § 121:

- I. Claims 10-17 and 19-26, drawn to a vaporizer, classified in class 261, subclass 66; and
- II. Claims 18 and 27, drawn to a chemical vapor deposition system, classified in class 118, subclass 726.